

PATENT

Docket No.: 1743/231

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT : Hiroyoshi ANDO
SERIAL NO. : (Con. of 09/811,714)
FILED : (Herewith)
FOR : SERVICE METHOD, SERVICE SYSTEM AND
MANUFACTURING/INSPECTION APPARATUS
ART UNIT : 2125 (Anticipated)
EXAMINER : S. P. Shechtman (Anticipated)

COMMISSIONER FOR PATENTS
P. O. Box 1450
Alexandria, Virginia 22313-1450

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. § 1.97 & § 1.98**

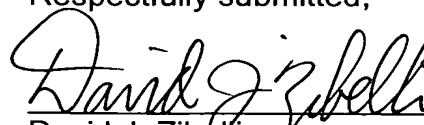
S I R:

In conformance with Applicant's duty of disclosure under 37 C.F.R. § 1.56 and § 1.97(b)(1), the references listed on the attached form PTO-1449 are hereby brought to the Examiner's attention.

Since all of the references have already been considered in parent application number 09/811,714, no copies of the references are required.

It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear in the "references cited" on any patent to issue therefrom.

Respectfully submitted,


David J. Zibelli
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Date: 10 March 2004

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FORM PTO-1449
INFORMATION DISCLOSURE
STATEMENT BY APPLICANT(S)

Atty Docket No. : 1743/231
 Serial No. : (Con. of 09/811,714)
 Inventors : Hiroyoshi ANDO
 Filed : (Herewith)
 Group Art Unit :
 Examiner :

U.S. PATENT DOCUMENTS

<u>Examiner Initial</u>	<u>Patent Number</u>	<u>Patent Date</u>	<u>Name</u>	<u>Class/ Subclass</u>	<u>Filing Date</u>
_____	6,185,474	02-2001	NAKAMURA et al.	700/121	
_____	6,385,497	05-2002	OGUSHI et al.	700/110	

FOREIGN PATENT DOCUMENTS

<u>Examiner Initial</u>	<u>Document Number</u>	<u>Date</u>	<u>Country</u>	<u>Class/ Subclass</u>	<u>Translation Yes No</u>

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner
Initial _____

- _____ 1. The Authoritative dictionary of IEEE Standards Terms 2000, 7th edition, Standards Information Network
- _____

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.